



Paper No. 8

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489 FIFTH AVENUE
NEW YORK NY 10017-6105

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JAN 10 2003

OFFICE OF PETITIONS

In re Application of :
Shi, Tay, Flynn, Tan, and Fulton : DECISION ACCORDING STATUS
Application No. 10/014,387 : UNDER 37 CFR 1.47(a)
Filed: 11 December, 2001 :
Attorney Docket No. GWS/18240CIP :

This is a decision in response to the renewed petition under 37 CFR 1.47(a) filed on 20 December, 2002.

The petition is GRANTED.

Petitioners have shown that the non-signing inventor cannot be found. Specifically, petitioners have shown, via the declaration of petitioner's counsel, Alan Israel, that a copy of the application sent to the non-signing inventor's last known address in Singapore. Additionally, despite attempts to determine a more recent address for the non-signing inventor, who is believed to now be residing in the United States, via telephone and Internet, the non-signing inventor could not be located.

This application and papers have been reviewed and found in compliance with 37 CFR 1.47(a). This application is hereby accorded Rule 1.47(a) status.

As provided in Rule 1.47(c), this Office will forward notice of this application's filing to the non-signing inventor at the address given in the petition, not the declaration. Notice of the filing of this application will also be published in the Official Gazette.

The application is being forwarded to the Office of Initial Patent Examination for further processing.

Telephone inquiries related to this decision should be directed to the undersigned at 703-308-6918.



Douglas I. Wood
Senior Petitions Attorney
Office of Petitions
Office of the Deputy Commissioner
for Patent Examination



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
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09-01-03

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OFFICE OF PETITIONS

In re Application of
Shi et al.
Application No. 10/014,387
Filed: 11 December, 2001
For: FILTERED CATHODE ARC SOURCE DEPOSITION APPARATUS

Dear Mr. Fulton:

You are named as a joint inventor in the above identified United States patent application, filed under the provisions of 35 U.S.C. 116 (United States Code), and 37 CFR 1.47(a), Rules of Practice in Patent Cases. Should a patent be granted on the application you will be designated therein as a joint inventor.

As a named inventor you are entitled to inspect any paper in the file wrapper of the application, order copies of all or any part thereof (at a prepaid cost per 37 CFR 1.19) or make your position of record in the application. Alternatively, you may arrange to do any of the preceding through a registered patent attorney or agent presenting written authorization from you. If you care to join the application, counsel of record (see below) would presumably assist you. Joining in the application would entail the filing of an appropriate oath or declaration by you pursuant to 37 CFR 1.63.

Telephone inquiries regarding this communication should be directed to the undersigned at 703/308-6918. Requests for information regarding your application should be directed to the File Information Unit at 703/308-2733. Information regarding how to pay for and order a copy of the application, or a specific paper in the application, should be directed to Certification Division at 703/308-9726 or 1-800-972-6382 (outside the Washington D.C. area).

Douglas I. Wood
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